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Xuping Zhang
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Changyuan Yu
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Contents

- vii *Authors*
- ix *Symposium Committees*
- xi *Conference Committee*

SESSION 1 INTEGRATED OPTICS AND PHOTONIC INTEGRATED CIRCUITS

- 10019 05 **Silicon nitride grating waveguide based directional coupler [10019-5]**

SESSION 2 DEVICES FOR PHOTONIC APPLICATIONS I

- 10019 07 **980 nm tapered lasers with photonic crystal structure for low vertical divergence [10019-7]**
- 10019 08 **Tunable multi-channel dropping filters based on double-waveguide parallel-coupled microring resonators [10019-8]**
- 10019 09 **The realization of optical switching generated from the combination of Ag/a-Si/p-Si memristor and silicon waveguide [10019-9]**
- 10019 0A **High efficiency single transverse mode photonic band crystal lasers with low vertical divergence [10019-10]**
- 10019 0B **Preparation and evaluation of perovskite solar cells in the absolute atmospheric environment [10019-19]**

SESSION 3 EMERGING OPTOELECTRONIC APPLICATIONS

- 10019 0C **Investigation of advanced pre- and post-equalization schemes in high-order CAP modulation based high-speed indoor VLC transmission system (Invited Paper) [10019-12]**
- 10019 0E **Optical implementation of neural learning algorithms based on cross-gain modulation in a semiconductor optical amplifier [10019-14]**
- 10019 0F **Detection of atmospheric boundary layer height in the plum rain season over Hangzhou area with three-dimensional scanning polarized lidar [10019-15]**
- 10019 0G **Design of real-time and high-precision photoelectric autocollimator [10019-16]**

SESSION 4 DEVICES FOR PHOTONIC APPLICATIONS II

- 10019 0H **Development of next-generation nanolithography methods to break the optical diffraction limit (Invited Paper)** [10019-17]
- 10019 0K **Gain-switched thulium-doped fiber laser with ultra-wide tuning range** [10019-20]
- 10019 0L **Er-doped fiber based Mach-Zehnder interferometer for simultaneous strain and temperature measurement** [10019-53]

SESSION 5 OPTICAL FIBERS

- 10019 0N **Mode evolution in polarization maintain few mode fibers and applications in mode-division-multiplexing systems (Invited Paper)** [10019-22]
- 10019 0P **Experimental measurement of effective refractive index difference for few mode polarization maintaining fibers using S^2 method** [10019-24]
- 10019 0Q **Uniform flat-top interleaver consisting of a two-stage cascaded Mach-Zehnder interferometer** [10019-25]
- 10019 0R **A distributed optical fiber sensing system for dynamic strain measurement based on artificial reflector** [10019-26]
- 10019 0S **Improved hybrid polymer/PbS quantum dot infrared phototransistors incorporating single-layer graphene** [10019-27]
- 10019 0T **A calibration method for photon counters using a customized standard light source** [10019-28]
- 10019 0U **Coupling between fiber-optic microring and lithium niobate microwaveguide chip towards photonic interlink devices** [10019-29]
- 10019 0V **Investigation on a novel fiber-optic sensor based on up-taper-core-offset-up-taper structure** [10019-52]

SESSION 6 PHOTONIC MATERIALS AND DEVICES/DETECTORS I

- 10019 0W **A simple and low cost method to fabricate well controllable silicon nanowires based on electrostatic adsorption of PS nanospheres** [10019-30]

SESSION 7 PHOTONIC MATERIALS AND DEVICES/DETECTORS II

- 10019 11 **Performance optimization of Pnp InGaAs/InP heterojunction phototransistors** [10019-36]
- 10019 12 **On-chip integration for in-plane video transmission using visible light** [10019-37]

POSTER SESSION

- 10019 13 **Optical characteristic analysis of optical fiber near-field and far-field** [10019-38]
- 10019 14 **Investigation on optical and acoustic fields of stimulated Brillouin scattering in As₂S₃ suspended-core optical fibers** [10019-39]
- 10019 15 **A short-range optical wireless transmission method based on LED** [10019-40]
- 10019 17 **Directional emission micro-cavity lasers with different device structures** [10019-42]
- 10019 18 **The research of multi-alkali vacuum photodiode on heating and illuminating** [10019-43]
- 10019 19 **Chromatic dispersion and polarization mode dispersion insensitive optical signal to noise ratio monitoring based on electronic variable optical attenuators and optical bandpass filter** [10019-44]
- 10019 1A **All-optical quantization by slicing supercontinuum in a Ge_{11.5}As₂₄Se_{64.5} rib waveguide** [10019-45]
- 10019 1B **High-performance transparent film heater with an embedded Ni metal-mesh based on selected metal electrodeposition process** [10019-46]
- 10019 1C **Multimode fiber focusing lens based on plasmonic structures** [10019-47]
- 10019 1D **High precision long-term stable fiber-based optical synchronization system** [10019-48]
- 10019 1E **A four-port vertical-coupling optical interface based on two-dimensional grating coupler** [10019-49]
- 10019 1F **RF spectral analysis for characterisation of mode-locked regimes in fibre lasers** [10019-50]
- 10019 1G **Solar cells based on InP/GaP/Si structure** [10019-51]

Authors

Numbers in the index correspond to the last two digits of the seven-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first five digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Akimoto, Ryoichi, 05	Kang, Shuai, 1A
Bai, Jian, 0F	Kang, Zhe, 1A
Cao, Mingxuan, 0S	Kobtsev, Sergey M., 1F
Chang, Junde, 19	Kokhanovskiy, Alexey, 1F
Che, Yongli, 0S	Kvitsiani, O., 1G
Chen, Ailin, 15	Laperashvil, D., 1G
Chen, Hongda, 1E	Laperashvili, T., 1G
Chen, Jun, 11	Le, Yansi, 0E
Chen, Li, 14	Li, Anyuan, 05
Chen, LinSen, 1B	Li, Dongyang, 09
Chen, Xiangcai, 14	Li, Hui, 08, 0Q
Chen, Xiangdong, 14	Li, Hui, 17
Chen, Yang, 0A	Li, Lianhuang, 13
Chen, Zhe, 0U	Li, Lunhua, 0A
Chen, Zhi, 0B	Li, Peng, 17
Cheng, Chuantong, 1E	Li, Ping, 15
Cheng, X., 0K	Li, Qiang, 0E
Cheng, Zhongtao, 0F	Li, Rao, 1D
Chi, Nan, 0C	Li, Wei, 09
Dang, Hongmei, 0B	Li, Wei, 0N, 0P
Ding, Li, 0H	Li, Xue, 14
Ding, Xin, 0S	Li, Yan, 0N, 0P
El-Zohary, Salah E., 0W	Li, Yanting, 0R
Fan, Wei, 1D	Li, Yuanhang, 12
Feng, Jijun, 05	Li, Yurong, 1D
Feng, Yuan, 17	Li, Z., 0K
Fu, Rongguo, 18	Lin, Peihua, 13
Gao, Tianxi, 1E	Lin, Shulang, 0T
Gao, Weiqing, 14	Lin, Yuzhe, 0A
Gao, Xumin, 12	Liu, Anjin, 0A
Gao, Yingming, 15	Liu, Bo, 19
Gu, Huarong, 0T	Liu, Chong, 0F
Guan, Chunying, 1C	Liu, Dong, 0F
Guang, Heyuan, 0U	Liu, Yanhua, 1B
Guo, Anran, 09	Liu, Yanyang, 0F
Guo, Guohui, 09	Liu, Yun, 07, 0A
Guo, Wenting, 0P	Liu, Z., 0K
Hao, Yong-qin, 17	Liu, Zhijian, 0N, 0P
Haraguchi, Masanobu, 0W	Lu, Huihui, 0U
Hou, J., 0K	Lu, Yongjiao, 1C
Hou, Jiayin, 0G	Luo, Huiwen, 0H
Hu, Jigang, 14	Luo, Jing, 0F
Hu, Xiaochuan, 1E	Ma, Xiaolong, 07
Huang, Beiju, 1E	Mei, Chao, 1A
Huang, Wenbin, 1B	Miao, Meiyuan, 15
Iguchi, Yusuke, 0W	Mikelashvili, V., 1G
Ivanenko, Alexey V., 1F	Mo, Qi, 0N, 0P
Jiang, Yadong, 09	Ni, Chenquan, 14
Jiang, Youen, 1D	Okamoto, Toshihiro, 0W

Qi, Aiyi, 0A
 Qiao, Wen, 1B
 Qiao, Zhi, 1D
 Qin, Jin, 0H
 Qu, Hongwei, 07, 0A
 Rao, Lan, 19
 Sang, Xinzhu, 1A
 Sarvari, Hojjatollah, 0B
 Shan, Yuanyuan, 0R
 Shen, Su, 1B
 Shen, Yibing, 0F
 Shi, Jian-wei, 17
 Shi, Jinhui, 1C
 Singh, Vijay, 0B
 Smirnov, Sergey V., 1F
 Song, Qinjian, 09
 Song, Xiaojia, 0E
 Song, Xiaoxian, 0S
 Su, Huaiyin, 0Q
 Sun, Chonghui, 0E
 Sun, Zhenhong, 0R
 Tan, Qiaofeng, 0T
 Tang, Peijun, 0F
 Tian, Feng, 19
 Tian, Qinghua, 19
 Wang, Guiyuan, 18
 Wang, Jia-bin, 17
 Wang, Jianlong, 0S
 Wang, Kaiwei, 0F
 Wang, Kuiru, 1A
 Wang, Kun, 18
 Wang, Liang, 0H
 Wang, Shanshan, 0G
 Wang, Xiaochao, 1D
 Wang, Xiaohui, 0B
 Wang, Yanyan, 1B
 Wang, Yiguang, 0C
 Wang, Yongjin, 12
 Wang, Yongjun, 19
 Wang, Yuan, 0U
 Wang, Zhi, 0E
 Wei, Yifang, 18
 Wu, Chongqing, 0E
 Wu, Jian, 0N, 0P
 Wu, Yongfeng, 08, 0Q
 Xin, Xiangjun, 19
 Xu, Peituo, 0F
 Xu, Qiang, 14
 Xu, Wei, 0L, 0V
 Xu, Yihang, 1C
 Yan, Binbin, 1A
 Yan, Chang-ling, 17
 Yang, Liu, 18
 Yang, Yongchao, 12
 Yang, Yongying, 0F
 Yao, Jianquan, 0S
 Ye, Yan, 1B
 Yin, Xiaoli, 19
 You, Shan hong, 0L, 0V
 Yu, Changqiu, 08, 0Q
 Yu, Changyuan, 0L, 0V
 Yu, Cheungchuen, 0L
 Yu, Chongxiu, 1A
 Yu, Jianhui, 0U
 Yu, Yu, 0S
 Yuan, Jialei, 12
 Yuan, Jinhui, 1A
 Yuan, Libo, 1C
 Yuan, Ping, 08, 0Q
 Yuan, Zijun, 14
 Zeng, Heping, 05
 Zeng, Xinglin, 0N, 0P
 Zhan, Zhenlin, 13
 Zhang, Chunyu, 08
 Zhang, Haiting, 0S
 Zhang, Jian-jia, 17
 Zhang, Lijia, 19
 Zhang, Lin, 1E
 Zhang, Na, 0L, 0V
 Zhang, Qi, 19
 Zhang, Wei, 14
 Zhang, Xianting, 1A
 Zhang, Xuping, 0R
 Zhang, Yanlei, 1A
 Zhang, Yating, 0S
 Zhang, Yixin, 0R
 Zhang, Yundong, 08, 0Q
 Zhang, Yupeng, 0F
 Zhang, Zan, 1E
 Zhang, Zanyun, 1E
 Zhao, Pengchao, 07
 Zhao, Shaoyu, 0A
 Zheng, Wanhua, 07, 0A
 Zheng, Xiaojie, 0U
 Zhou, Siyu, 0G
 Zhou, Suxu, 0U
 Zhou, Xuyan, 0A
 Zhou, Yudi, 0F
 Zhou, Yun, 1B
 Zhu, Min, 11
 Zhu, Mingxing, 15
 Zhu, Qiudong, 0G
 Zhu, Zheng, 1C
 Zou, Nianyu, 15

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